



PATENT APPLICATION

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11/17/03
Date

Delbert J. Barnard
Delbert J. Barnard
Registration No. 20,515

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2878
Examiner: Shun K. Lee
Applicant: Ger van den Engh
Serial No.: 09/847,466
Filed: May 1, 2001
For: APPARATUS FOR DETERMINING RADIATION BEAM ALIGNMENT
Date: November 17, 2003

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PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the due date for filing a Response to the Office Action dated September 16, 2003, be extended from October 16, 2003 to November 17, 2003 (November 15, 2003 and November 16, 2003 being a Saturday and Sunday).

A check for the extension fee of \$55.00 as set forth in 37

C.F.R. 1.17(a) is enclosed. Please charge any additional extension fees to Deposit Account No. 02-0915. Two duplicate copies of this Petition are enclosed.

Respectfully submitted,

GER VAN DEN ENGH

By: 

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DJB/lam